

Notice of References Cited	Application/Control No. 10/019,332	Applicant(s)/Patent Under Reexamination SHINO ET AL.	
	Examiner Danny Wai Lun Leung	Art Unit 2633	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,432,874	07-1995	Muraguchi, Takahiro	385/24
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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	J	US-			
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	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
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NON-PATENT DOCUMENTS

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